



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 10/647,297 Group Art Unit: 1771
Filing Date: August 26, 2003 Examiner: Hai Vo
Applicant: Hyun HUH et al.
Title: Polishing Pad Containing Embedded Liquid Microelements
and Method of Manufacturing the Same
Attorney Docket: 47881-000003/US

Customer Service Window
Randolph Building
401 Dulany Street
Alexandria, VA 22314
Mail Stop Amendment

October 3, 2006

AMENDMENT

Sir:

In response to the Office Action mailed May 9, 2006, the period for response having been extended two months to October 9, 2006, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

Amendments to the Specification begin on page 2 of this Amendment.

Listing of the Claims begin on page 3 of this Amendment.

Remarks begin on page 9 of this Amendment.

| | | | | | |
|-------------|-------------------------------------|---|---------------------------------------|---|---------------|
| | Claims remaining after Amendment | | Highest number previously paid for | | Present extra |
| Total | 31 | - | 31 | = | 0 |
| Independent | 2 | - | 2 | = | 0 |